

IFW

Applicant: Pei-Yang Yan § Group Art Unit: 1756
Serial No.: 10/631,171 §
Filed: July 31, 2003 § Examiner: Stephen D. Rosasco
For: Multilayer Reflective Extreme § Atty. Dkt. No.: ITL.0952US
Ultraviolet Lithography Mask § (P15976)
Blanks §

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


INFORMATION DISCLOSURE STATEMENT

Dear Sir:

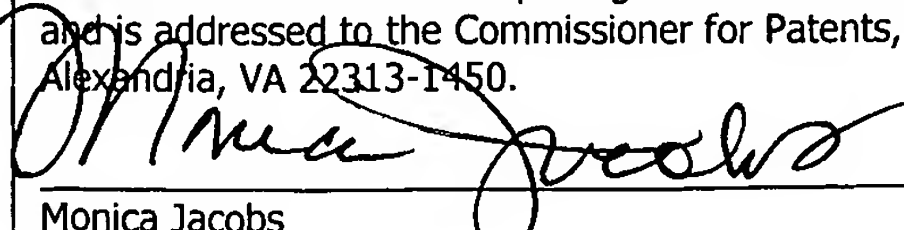
Applicant submits the references listed on the attached form PTO 1449, copies of which are enclosed. A copy of a communication dated June 27, 2005 from a foreign patent office in a counterpart application is also enclosed. I, the undersigned, hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.0952US).

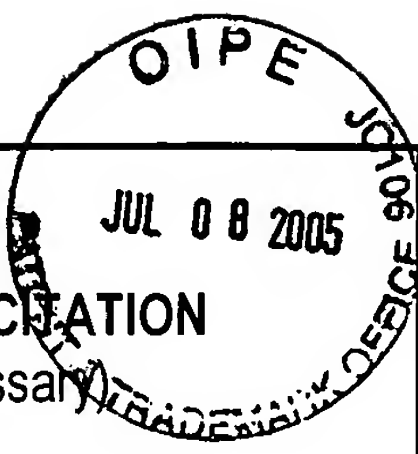
Respectfully submitted,

July 6, 2005
Date


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Date of Deposit: July 6, 2005
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Monica Jacobs

**"INFORMATION DISCLOSURE CREATION**

(Use several sheets if necessary)

ATTY DOCKET NO.

ITL.0952US (P15976)

SERIAL NO.

10/631,171

APPLICANT(S):

Pei-Yang Yan

FILING DATE:

July 31, 2003

GROUP ART UNIT:

1756

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.						
	B.						
	C.						
	D.						
	E.						

U.S. PATENT APPLICATION PUBLICATIONS

	F.	US 2003/0008180	01/09/2003	Bajt et al.			
	G.	US 2003/0031937	02/13/2003	Yan			
	H.	US 2003/0123605	07/03/2003	Rau			
	I.	US 2004/0002009	01/01/2004	Yan			
	J.						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	K.	EP 1 065 568	01/03/2001	Europe				
	L.	EP 1 394 815	03/03/2004	Europe				
	M.	JP 2003-249434	09/05/2003	Japan			Abstract Only	
	N.							
	O.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	P.	M. Singh et al., <i>Capping Layers For Extreme-Ultraviolet Multilayer Interference Coatings</i> ; Optics Letters, Optical Society of America, Washington, Vol. 26, No. 5, March 1, 2001, pgs. 259-261.					
	Q.						
	R.						
	S.						
	T.						
	U.						
	V.						

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.